



JOHN H. JONES, PTO 11 DEC 2001

Attorney Docket: 155/50324

#3

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: SHINCHIRO YAGI  
Serial No.: 09/914,044  
Filed: AUGUST 22, 2001  
Title: INSPECTION OBJECT SILICON WAFER FOR THE PURPOSE OF  
DETECTING CRYSTAL DEFECTS AND THE METHOD OF  
DETECTING THEREOF

SUBMISSION OF MISSING PARTS IN APPLICATION

Box PCT

Commissioner for Patents  
Washington, D.C. 20231

Sir:

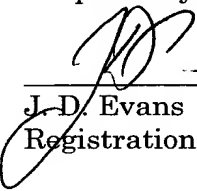
Attached hereto please find:

1. A copy of the Notice to File Missing Requirements Under 35 U.S.C. 371 in the United States Designated/Elected Office (DO/EO/US).
2. The executed Declaration and Power of Attorney.
3. Assignment for recordation.
4. Corrected Application Data Sheet, to correct the spelling of the inventor's first name.
5. A check in the amount of \$40.00 in payment of the Assignment recordation fee. (The basic filing fee, including the surcharge for late submission of the Declaration, was submitted on August 22, 2001).

Please credit any overpayments or charge any additional fees to the Deposit Account of Crowell & Moring LLP, Account Number 05-1323 (Docket #155/50324). A duplicate copy of this letter is attached.

Respectfully submitted,

December 11, 2001

  
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29368.025

Combinator For Priority, See PCT, United States Patent and Trademark Office, Washington, D.C. 20531, www.uspto.gov

U.S. APPLICATION NUMBER NO.	FIRST NAMED APPLICANT	ATTY. DOCKET NO.
09/914,044	Shinichiro Yagi	155/50324

INTERNATIONAL APPLICATION NO.
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PCT/JP00/09135

I.A. FILING DATE	PRIORITY DATE
12/22/2000	12/24/1999

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Crowell & Morning  
1200 G Street NW Suite 700  
Washington, DC 20005

CONFIRMATION NO. 8468

371 FORMALITIES LETTER



\*OC000000006867735\*

Date Mailed: 10/11/2001

Date: 12/11/01 docketed DB

### NOTIFICATION OF MISSING REQUIREMENTS UNDER 35 U.S.C. 371 IN THE UNITED STATES DESIGNATED/ELECTED OFFICE (DO/EO/US)

The following items have been submitted by the applicant or the IB to the United States Patent and Trademark Office as a Designated Office (37 CFR 1.494):

- U.S. Basic National Fees
- Priority Document
- Copy of references cited in ISR
- Copy of the International Application
- Copy of the International Search Report
- Information Disclosure Statements

The following items **MUST** be furnished within the period set forth below in order to complete the requirements for acceptance under 35 U.S.C. 371:

- Oath or declaration of the inventors, in compliance with 37 CFR 1.497(a) and (b), identifying the application by the International application number and international filing date.

**ALL OF THE ITEMS SET FORTH ABOVE MUST BE SUBMITTED WITHIN TWO (2) MONTH FROM THE DATE OF THIS NOTICE OR BY 22 or 32 MONTHS (where 37 CFR 1.495 applies) FROM THE PRIORITY DATE FOR THE APPLICATION, WHICHEVER IS LATER. FAILURE TO PROPERLY RESPOND WILL RESULT IN ABANDONMENT.**

The time period set above may be extended by filing a petition and fee for extension of time under the provisions of 37 CFR 1.136(a).

Applicant is reminded that any communications to the United States Patent and Trademark Office must be mailed to the address given in the heading and include the U.S. application no. shown above (37 CFR 1.5)

WINSTON M ALVARADO

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PART 1 - ATTORNEY/APPLICANT COPY

U.S. APPLICATION NUMBER NO.	INTERNATIONAL APPLICATION NO.	ATTY. DOCKET NO.
09/914,044	PCT/JP00/09135	155/50324